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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application	)	Art Unit: 1765
Applicant: Kozo Nakamura	)	Confirmation No.: 6736
Serial No.: 09/856,209	)	
Filed: May 18, 2001	)	
For: **SILICON CRYSTAL AND PRODUCTION METHOD FOR SILICON SINGLE CRYSTAL WAFER**	)	
Examiner: Matthew J. Song	)	

I hereby certify that this correspondence is being deposited with the United Postal Service as first class mail in an envelope addressed to: Mail Stop RCE / Commissioner for Patents / PO Box 1450 / Alexandria, Virginia 22313-1450, on August 1, 2003:

Gerald T. Shekleton

Gerald T. Shekleton Reg. No. 27,466

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MW

AMENDMENT

MAIL STOP RCE
Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

Sir:

The Advisory Action of June 26, 2003 has been carefully reviewed in conjunction with the previous Office Action of March 4, 2003 and the following amendments and remarks are made in response thereto.

A Petition for Extension of Time Under 37 CFR 1.136(a) is enclosed.